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| Search Notes  | Application/Control No. 10567070 | Applicant(s)/Patent Under Reexamination VAN DUUREN, MICHIEL JOS |
| | Examiner Lappas, Jason | Art Unit 2827 |

| SEARCHED | | | |
|----------|---------------------------------------|------------|----------|
| Class | Subclass | Date | Examiner |
| 365 | 210 | 2/22/2007 | JL |
| 365 | 210 | 6/25/2008 | JL |
| 365 | 210.1, 185.21, 185.33, 189.07, 185.21 | 10/22/2008 | JL |

| SEARCH NOTES | | |
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| Search Notes | Date | Examiner |
| East | 2/22/2007 | JL |
| EAST | 6/25/2008 | JL |
| See EAST | 10/22/2008 | JL |

| INTERFERENCE SEARCH | | | |
|---------------------|----------|------|----------|
| Class | Subclass | Date | Examiner |
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